

02-21-2003



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Form PTO-1594 (Rev. 03/01) OMB No. 0651-0027 (exp. 5/31/2002) Tab settings

U.S. DEPARTMENT OF COMMERCE U.S. Patent and Trademark Office

To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

Molecular Imprints, Inc.

- Individual(s) Association General Partnership Limited Partnership Corporation-State DE Other

Additional name(s) of conveying party(ies) attached? Yes No

3. Nature of conveyance:

- Assignment Merger Security Agreement Change of Name Other

Execution Date: 1/31/03

2. Name and address of receiving party(ies)

Name: Venture Lending & Leasing III, Inc.

Internal Address:

Street Address: 2010 First Street

City: San Jose State: CA Zip: 95131

- Individual(s) citizenship Association General Partnership Limited Partnership Corporation-State Maryland Other

If assignee is not domiciled in the United States, a domestic representative designation is attached: Yes No (Designations must be a separate document from assignment) Additional name(s) & address(es) attached? Yes No

4. Application number(s) or registration number(s):

A. Trademark Application No.(s) 76/453,571 76/453,319; 76/453,866; 76/453,858

219103

B. Trademark Registration No.(s)

Additional number(s) attached Yes No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Russell D. Pollock, Esq.

Internal Address:

Street Address: Greene Radovsky Maloney & Share LLP Four Embarcadero Center, Suite 4000

City: San Francisco State: CA Zip: 94111

6. Total number of applications and registrations involved:

6

7. Total fee (37 CFR 3.41) \$ 165.00

- Enclosed Authorized to be charged to deposit account

8. Deposit account number:

OFFICE OF PATENT RECORDS 2003 FEB 19 AM 9:00 FINANCE SECTION

DO NOT USE THIS SPACE

9. Signature.

Russell D. Pollock

Name of Person Signing

Signature

2/10/03

Date

Total number of pages including cover sheet, attachments, and document: 7

Mail documents to be recorded with required cover sheet information to: Commissioner of Patent & Trademarks, Box Assignments Washington, D.C. 20231

02/20/2003 EDDOPER 0000006 76453571

01 FC:8521 02 FC:8522

40.00 BP 125.00 BP

TRADEMARK REEL: 002674 FRAME: 0970

RECORDATION FORM COVER SHEET
FOR MOLECULAR IMPRINTS, INC. CONTINUED

Number 4a. Application Numbers Continued

76/470,850

76/470,855

INTELLECTUAL PROPERTY SECURITY AGREEMENT

This Supplement No. 1 to Intellectual Property Security Agreement (this "Supplement") is made as of January 31, 2003, by and between MOLECULAR IMPRINTS, INC., a Delaware corporation ("Grantor"), and VENTURE LENDING & LEASING III, INC., a Maryland corporation ("Secured Party").

RECITALS

A. Grantor and Secured Party are parties to that certain Intellectual Property Security Agreement dated as of October 1, 2002 (the "Intellectual Property Security Agreement") pursuant to which, among other things, Grantor granted Secured Party a security interest in, to and under certain items of Grantor's Intellectual Property.

B. Grantor and Secured Party wish to amend the Intellectual Property Security Agreement to include reference to certain Patents and Trademarks acquired by Grantor after the execution thereof.

C. Each capitalized term used but not otherwise defined herein shall have the meaning ascribed thereto in the Intellectual Property Security Agreement.

NOW, THEREFORE, THE PARTIES HERETO AGREE AS FOLLOWS:

1. Exhibit B to the Intellectual Property Security Agreement, the listing of Grantor's Patents, is hereby supplemented and amended by Exhibit "B" attached to this Supplement, to include reference to Grantor's right, title and interest in, to and under the Patents set forth thereon.

2. Exhibit C to the Intellectual Property Security Agreement, the listing of Grantor's Trademarks, is hereby supplemented and amended by Exhibit "C" attached to this Supplement, to include reference to Grantor's right, title and interest in, to and under the Trademarks set forth thereon

3. This Supplement shall be deemed to be an amendment to the Intellectual Property Security Agreement and shall not be construed in any way as a replacement or substitution therefor. All of the terms and conditions of, and terms defined in, this Supplement are hereby incorporated by reference into the Intellectual Property Security Agreement as if such terms and provisions were set forth in full therein. Except as so amended hereby, the Intellectual Property Security Agreement and the other Loan Documents shall remain in full force and effect in accordance with their respective terms.

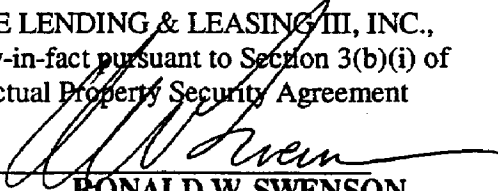
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IN WITNESS WHEREOF, the parties hereto have executed this Supplement on the day and year first above written.

GRANTOR:

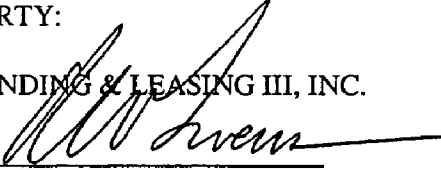
MOLECULAR IMPRINTS, INC.

By: VENTURE LENDING & LEASING III, INC.,
as attorney-in-fact pursuant to Section 3(b)(i) of
the Intellectual Property Security Agreement

By: 
Name: RONALD W. SWENSON
Title: CHIEF EXECUTIVE OFFICER

SECURED PARTY:

VENTURE LENDING & LEASING III, INC.

By: 
Name: RONALD W. SWENSON
Title: CHIEF EXECUTIVE OFFICER

SUPPLEMENT NO. 1

TO

EXHIBIT B

Patents

<u>Description</u>	<u>Registration/Serial Number</u>	<u>Registration/Application Date</u>
Methods of Manufacturing a Lithography Template	10/136,188	05/01/2002
Method and Apparatus for Whole Wafer Planarization Using Optical Flats and Light Curable Liquids	60/394,458	07/08/2002
System and Method for Dispensing Liquids	10/191,749	07/09/2002
Formation of Discontinuous Films During an Imprint Lithography Process	10/194,411	07/11/2002
Step and Repeat Imprint Lithography Process	10/194,991	07/11/2002
Step and Repeat Imprint Lithography Systems	10/194,414	07/11/2002
Method and System for Fabricating Nanoscale Patterns Using an Electric Field	10/194,410	07/11/2002
Scatterometry Alignment for Imprint Lithography	10/210,785	08/01/2002
Alignment Systems for Imprint Lithography	10/210,894	08/01/2002
Alignment Methods for Imprint Lithography	10/210,780	08/01/2002
A Method of Forming a Layer on a Substrate to Facilitate Fabrication of Metrology Standards	10/264,926	10/04/2002
Functional Patterning Material for Imprint Lithography Processes	10/235,314	09/05/2002
Method and System for Determining	10/318,365	12/12/2002

Characteristics of Substrates Employing
Fluid Geometries

Method of Reducing Pattern Distortions During Imprint Lithography Processes	10/293,223	11/13/2002
A Method and a Mold to Arrange Features on a Substrate to Replicate Features Having Minimal Dimensional Variability	10/264,960	10/04/2002
Mass Production of Photonic Crystals and Optical Components	preparing for filing	
A Chucking System for Modulating Shapes of Substrates	10/293,224	11/13/2002
A Method for Modulating Shapes of Substrates	not assigned	12/11/2002
Methods of Inspecting a Lithography Template	10/293,919	11/13/2002
Method and System for Magnification and Distortion Control for Layer-to-Layer Alignment in Imprint Lithography	60/432,584	12/11/2002
Surface Activation Monomer	preparing for filing	
Method and System for Magnification and Distortion Control for Layer-to-Layer Alignment in Imprint Lithography	60/433,477	12/13/2002
Method for Fabricating Bulbous-Shaped Vias	10/227,105	08/23/2002

SUPPLEMENT NO. 1

TO

EXHIBIT C

Trademarks

<u>Description</u>	<u>Registration/Serial Number</u>	<u>Registration/Application Date</u>
S-FIL	76/453,571	09/27/2002
SFIL	76/453,319	09/26/2002
S-FIL	76/453,866	09/30/2002
SFIL	76/453,858	09/30/2002
IMPRIO	76/470,850	11/29/2002
IMPRIO	76/470,855	11/29/2002